Characterization of Epitaxial LSMO Films Grown on STO Substrates

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Epitaxial manganite La\textsubscript{0.67}Sr\textsubscript{0.33}MnO\textsubscript{3} (LSMO) layers, with a thickness of 20–50 nm, are prepared on single crystal (001) SrTiO\textsubscript{3} (STO) substrates by pulsed laser deposition technique. Structural characterization (composition analysis, surface morphology), investigated by the Rutherford backscattering spectroscopy and atomic force microscopy, reveals the growth of stoichiometric LSMO films with a smooth surface (root-mean-square value of 0.21–1.6 nm). The prepared LSMO films possess high Curie temperature (≈ 412 K), low room temperature resistivity (1–2 mΩ cm) and maximum of temperature coefficient of resistivity TCR = 2.7% K\textsuperscript{−1} at 321 K.

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1. Introduction

Perovskite manganites with general formula A\textsubscript{1−x}B\textsubscript{x}MnO\textsubscript{3} (where A is a lanthanum (La) and B an alkaline-earth (Ba, Ca, Sr) element) have attracted much attention due to the observation of a colossal magnetoresistance (CMR) effect [1, 2]. The CMR effect occurs in the 0.2 > x > 0.5 doping range. Among these materials La\textsubscript{1−x}Sr\textsubscript{x}MnO\textsubscript{3} group (La\textsubscript{0.7}Sr\textsubscript{0.3}MnO\textsubscript{3}, La\textsubscript{0.67}Sr\textsubscript{0.33}MnO\textsubscript{3}) has been studied intensively because of their high Curie temperature \(T_{C, bulk} \approx 370\) K. Manganite thin films have many potential applications exploiting their magnetic properties, e.g. low-cost magnetic sensors and high-density memory applications [3].

In this work we investigate structural, magnetic, and electrical properties of epitaxial La\textsubscript{0.67}Sr\textsubscript{0.33}MnO\textsubscript{3} (LSMO) thin films deposited by pulsed laser deposition. The films were grown on single crystalline substrates (001) SrTiO\textsubscript{3} (STO). The quality of the film was proved by structural as well as physical properties characterization.

2. Experimental

The bulk manganite LSMO can be described as a slightly deformed pseudocubic perovskite lattice with a lattice parameter \(a_{bulk} = 0.3876\) nm and a unit cell angle 90.26°. The STO substrate has a cubic structure with a lattice parameter of 0.3905 nm. The lattice mismatch between the bulk LSMO and the STO substrate is 0.75%, inducing biaxial tensile strain in the LSMO films.

The LSMO films were deposited onto a one-side polished (001) oriented single crystalline STO substrates using pulsed laser deposition (PLD) system (MBE/PLD-2000). A KrF excimer laser operating at 248 nm with a pulse width of 20 ns, repetition rate of 10 Hz and energy density of 6 J/cm\textsuperscript{2} was used to grow the LSMO films. The temperature of the substrate holder was kept to 850°C and the oxygen pressure was set to 53 Pa during the deposition. After the deposition, the films were cooled down at a rate of 20°C/min in O\textsubscript{2} (4 × 10\textsuperscript{4} Pa). The thickness of the LSMO films were deduced from the growth rate of the films (6.5 nm/min) and X-ray reflectivity measurements. It was varied between 20 and 50 nm.

The Rutherford backscattering spectrometry (RBS) measurements were performed on Van de Graaff accelerator using 3.055 MeV H\textsuperscript{2+} ions with an angle between the sample surface and the beam 30°. The backscattered particles were detected at 170° with respect to the incident beam.

The surface morphology of the LSMO films was examined by atomic force microscopy (AFM) carried out on NT-MDT NTegra Aura in semicontact mode.

The temperature dependence of the resistivity was measured using a standard dc four-probe technique in a temperature range of 4–480 K. The magnetic properties of the films were measured at temperatures ranging from 10 to 500 K, using a SQUID magnetometer (MPMS-XL7) and a vibrating sample magnetometer (PPMS-9T), all from Quantum Design. The magnetization vs. temperature \((M(T))\) measurements were performed in the field of 5 mT applied in the film plane.

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3. Results and discussion

The prepared LSMO films exhibited very good crystal quality. X-ray diffraction analyses confirmed that our LSMO grew epitaxially on the STO substrates [4].

The LSMO films exhibit a homogeneous distribution of all presented elements in the film through the whole film thickness. The calculated composition of the examined LSMO film obtained from the RBS measurement is $\text{La}_{0.65}\text{Sr}_{0.35}\text{Mn}_{1.04}\text{O}_{2.96}$, i.e. the average cation composition ratio La:Sr:Mn of the film corresponds to the target composition.

Fig. 1. RBS spectrum of a 30 nm thick LSMO grown on STO. The collected RBS data were analysed using BS software.

The morphology of the film surface, analysed by AFM, is generally smooth for the LSMO films of different thickness. In the case of a 20 nm thick LSMO film the root-mean-square (RMS) value is 0.21 nm for the $1 \times 1 \mu m^2$ area. The surface is composed of grains with a mean diameter size of 20 nm (Fig. 2).

Fig. 2. AFM surface image of a 20 nm (a) and a 50 nm (b) thick LSMO film. The surface consists of uniformly distributed crystallites with a dimension of 20 nm and 40 nm, respectively.

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Fig. 3. Temperature dependence of magnetization of a 20 nm thick LSMO film grown on STO substrate. $T_C$ indicates the transition PM to FM state. Inset shows the resistivity vs. temperature dependence of this film with maximum at temperature $T_{mi}$.

roughness and the size of the crystallites increases with the film thickness — for a 50 nm thick LSMO the RMS value of 1.6 nm and the grain size of about 40 nm were detected.

STO with a small lattice misfit to the LSMO (0.75%) is a suitable substrate for the preparation of LSMO thin films with high Curie temperature ($T_C$) and low resistivity $\rho$ as it is shown in Fig. 3. The $T_C$ of the LSMO film was determined from the temperature dependence of magnetization at 412 K as the temperature of paramagnetic(PM)($M = 0$)/ferromagnetic(FM)($M > 0$) transition. The temperature of resistivity maximum $T_{mi}$ (corresponding to metal–insulator transition) (Fig. 3, inset) was estimated at temperature $T_{mi} = 412$ K. The $T_C$ and $T_{mi}$ values coincide according to double-exchange theory explaining the ferromagnetic properties of manganites. The typical room temperature resistivity is about 1–2 m$\Omega$cm and maximal resistivity changes were observed at the temperatures around 330 K. The maximum of temperature coefficient of resistivity $\text{TCR} = 2.7\% \text{K}^{-1}$ was achieved at 321 K. Moreover, Méchin et al. [5] found that the level of $1/f$ noise at room temperature decreases with increased value of $T_{mi}$, therefore the presented LSMO thin film with $T_{mi} = 412$ K seems to be a good candidate for room temperature application as sensor.

In our previous works [6, 7] we presented the polynomial fit expression $\rho(T) = \rho_0 + a_2 T^2 + a_N (T - T_0)^{4.5}$, well describing the electrical and magnetotransport properties of the LSMO film in a wide range of temperature (2–380 K) and magnetic field 0–9 T. In this paper we demonstrate the approximation of $\rho(B)$ dependences taken at various temperatures (Fig. 4, inset). At first, the $\rho(T,B)$ dependences were measured and approximated (Fig. 4, main part). From these approximations we can determine the magnetic field dependences of fitting parameters $\rho_0(B)$, $a_2(B)$, $a_N(B)$, $T_0(B)$ [7] and then subsequently approximate the $\rho(B)$ dependences at a given
Fig. 4. Main part: temperature dependences of resistivity of a 20 nm thick LSMO film in magnetic field 0, 3, and 6 T (points) and approximations (full lines) with polynomial expression. Inset: the dependences of resistivity on applied magnetic field at various temperatures (points) and approximations (full lines) using polynomial fit expression with magnetic field dependent fitting parameters.

temperature. The reason for approximation of electrical and magnetic properties of the LSMO is to analyze individually each component of the total LSMO resistivity \( \rho \).

4. Conclusions

Structural, electrical and magnetotransport properties of LSMO films grown on STO substrates have been studied. We presented the possibility to approximate the dependences of the resistivity on applied magnetic field in temperature range of 150–350 K where the largest magnetoresistivity of the films was observed. The epitaxial LSMO films exhibited significantly higher temperature of metal–insulator transition \( T_{mi} \), as well as the Curie temperature than it was presented for the bulk LSMO. Since high \( T_{mi} \) corresponds to low noise, the investigated LSMO films are considered to be a good candidate in room temperature sensor applications.

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